

<b>Notice of References Cited</b>	Application/Control No. 10/783,227	Applicant(s)/Patent Under Reexamination TAGA ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,652,767	07-1997	Kiyonaga et al.	375/317
	B	US-6,496,552 B2	12-2002	Tomofuji et al.	375/373
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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